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Complete if Known Substitute for form 1449A/B/PTO Application Number 10/801,766 INFORMATION DISCLOSURE Filing Date March 16, 2004 STATEMENT BY APPLICANT First Named Inventor David B Mitzi Art Unit 2814 (Use as many sheets as necessary) Examiner Name Long Pham 20140-00339-US1 Sheet 1 of 1 Attorney Docket Number

U.S. PATENT DOCUMENTS					
Examiner	CHO	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
1	Oite ONo.1	Number-Kind Code ² (if known)			
F	AA	US-6,379,585-B1	04-30-2002	Vecht et al.	

FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No.1	Foreign Patent Document Country Code ³ -Number ⁴ -Kind Code ⁴ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T°	

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NON PATENT LITERATURE DOCUMENTS					
Examiner Initials		Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		
7	P	CA	"The Use of Soluble Metal-Polyselenide Complexes as Precursors to Binary and Temary Solid Metal Selenides" by Dhingra et al., Mat. Res. Soc. Symp. Proc. Vol. 180, 1990, pages 825-830		
		СВ	"Successive ionic layer adsorption and reaction (SILAR) method for the deposition of large area (~10cm ²) tin disulfide (SnS ₂) thin films" Sankapal et al., Materials Research Bulletin 35 (2000) pages 2027-2035		
		CC	"Polycrystalline CdSe Films for Thin Film Transistors" Van Calster et al., Journal of Crystal Growth 86 (1988) pages 924-928		
		CD	"Preparation of Thin-Film Transistors with Chemical Bath Deposited CdSe and CdS Thin Films" Gan et al., IEEE Transactions on Electron Devices, Vol. 49, No. 1, January 2002, pages 15-18		
	T	CE	"Spin-coated amorphous chalcogenide films" Chern et al., J. Appl. Phys. 53 (10), October 1982, pages 6979-6982		
	T	CF	"Spin-Coating of MoS ₂ Thin Films" Pütz et al., Institut für Neue Materialien - INM, Department of Coating Technology, Im Stadtwald, Geb. 43, D-66123 Saarbrücken, Germany, 6 pages		
		CG	"Solution processed CdS thin film transistors" Schön et al., Thin Solid Films 385 (2001) pages 271-274		
		СН	"A Novel Method for the Preparation of Inorganic Sulfides and Selenides" I. Binary Materials and Group II-VI Phosphors, Davies et al., Journal of the Electrochemical Society, 147 (2), pages 765-771 (2000)		
		CI	"All-Inorganic Field Effect Transistors Fabricated by Printing" Ridley et al., October 22, 1999, Vol. 286, Science, pages 746-749		
		CJ	"A Method for the Clean Syntheses of Sulfides/Selenides" II. Ternary Sulfides/Selenides, Marsh et al., Journal of the Electrochemical Society, 148 (7) pages D89-D93 (2001)		
		CK	"Electrical Characterization of 2H-SnS ₂ Single Crystals Synthesized by the Low Temperature Chemical Vapor Transport Method" Shibata et al., J. Phys. Chem. Solids Vol. 52, No. 3, pages 551-553, 1991		

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